

10/586476

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**OLIFF & BERRIDGE, PLC**  
ATTORNEYS AT LAW

**Application Data Sheet**

**Applicant Information**

Applicant Authority type:: Inventor  
Primary Citizenship Country:: Japan  
Status:: Full Capacity  
Given Name:: Makoto  
Family Name:: IIDA  
City of Residence:: Fukushima  
Country of Residence:: Japan

**Correspondence Information**

Correspondence Customer Number:: 25944

**Application Information**

Application Type:: National Phase  
Subject Matter:: Utility  
CD-ROM or CD-R:: None  
Title:: A METHOD FOR PRODUCING SEMICONDUCTOR WAFERS AND A SYSTEM FOR DETERMINING A CUT POSITION IN A SEMICONDUCTOR INGOT  
Attorney Docket Number:: 128768  
Suggested Drawing Figure:: 1  
Total Drawing Sheets:: 3  
Small Entity:: No

**Representative Information**

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Domestic Priority Information	
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Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application is a	National Phase of	PCT/JP2005/000641	01/20/05
<b>Foreign Priority Information</b>			
Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2004-026887	02/03/04	Yes
<b>Assignee Information</b>			
Assignee Name::	Shin-Etsu Handotai Co., Ltd.		
Street of mailing address::	4-2, Marunouchi 1-chome		
City of mailing address::	Chiyoda-ku		
State or Province of mailing address::	Tokyo		
Country of mailing address::	Japan		